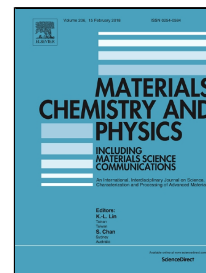


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Shiping Zhao^b, Yunxian Cui^a, Hualin Wang^{b, c, d}, Shimin Liu^{b, c, d}, Chaoqian Liu^{b, c, d},
Nan Wang^{b, c, d}, Weiwei Jiang^{b, c, d}, Weiping Chai^{b, c, d}, Wanyu Ding^{a, b, c, d*}

^a College of Mechanical Engineering, Dalian Jiaotong University, Dalian 116028,
China.

^b College of Materials Science and Engineering, Dalian Jiaotong University, Dalian
116028, China

^c Engineering Research Center of Optoelectronic Materials and Devices, Education
Department of Education of Liaoning Province, Dalian 116028, China

^d Engineering Research Center of Optoelectronic Materials and Devices, Bureau of
Science and Technology of Dalian City, Dalian 116028, China

* **Corresponding author:** Prof. Wanyu Ding

E-mail: dwyysd_2000@163.com, dwyysd@djtu.edu.cn, Tel: +86-411-84106876, Fax:
+86-411-84105118.

Address: College of Materials Science and Engineering, Dalian Jiaotong University,
No. 794 Huanghe Road, Shahekou District, Dalian, Liaoning
Province/116028, China.

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